



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2002
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TECHNOLOGY CENTER 28

Applicant: Paul A. Farrar et al.
Title: THERMAL PROCESSING OF METAL ALLOYS FOR AN IMPROVED CMP PROCESS IN INTEGRATED CIRCUIT FABRICATION
Docket No.: 303.469US3
Filed: August 30, 2001
Examiner: Caridad Everhart

Serial No.: 09/945,536
Due Date: December 5, 2002
Group Art Unit: 2825

Commissioner for Patents
Washington, D.C. 20231

We are transmitting herewith the following attached items (as indicated with an "X"):

- A return postcard.
- An Amendment and Response (4 Pages).
- An Information Disclosure Statement (1 pg.), Form 1449 (1 pg.), and copies of 3 cited references.
- A check in the amount of \$180.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).
- Clean Version of Pending Claims (6 pgs.).

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.

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(GENERAL)

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on this 5th day of December, 2002.